



**RESPONSE UNDER 37 C.F.R. § 1.116
-EXPEDITED PROCEDURE-
EXAMINING GROUP ART GROUP UNIT 1765**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Athavale et al.

Examiner: Deo, Duy Vu Nguyen

Serial No: 09/757,123

Group Art Unit: 1765

Filed: January 9, 2001

Docket: 01 P7408 US 02 (8055-142)

For: **METHOD FOR DRY ETCHING DEEP TRENCHES IN A SUBSTRATE**

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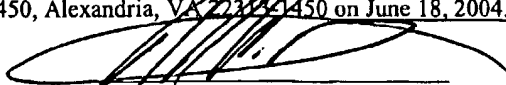
AMENDMENT

This is a response to the Final Office Action mailed on April 20, 2004 . Please consider
the following amendments and remarks to the above-identified application:

CERTIFICATE OF MAILING 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is
being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to:
Mail Stop AF, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22312-1450 on June 18, 2004.

Dated: *18 June 2004*


Thomas W. McNally